

Electronic Acknowledgement Receipt

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Application Number:	10670855
International Application Number:	
Confirmation Number:	9751
Title of Invention:	APPARATUS FOR POLISHING A SEMICONDUCTOR WAFER AND METHOD THEREFOR
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Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
1	Miscellaneous Incoming Letter	0225DIVtransmittal.pdf	67423	no	1
			06a9115904b03609c25f329431c0cffe9c51286240		

Warnings:

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2	Request for Certificate of Correction	0225DIVpetforcertofcorr.pdf	379285	no	4
			#f7a567c096c1e5c61bb65a7e4d0056c21f1b3059		

Warnings:

Information:

3	Fee Worksheet (PTO-06)	fee-info.pdf	8187	no	2
			2555491d7ea0d522ba42b-4ef3c3c25509101a7035d1		

Warnings:

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